

Search Notes

Application/Control No.

10/635,800

Examiner

John Rivell

Applicant(s)/Patent under
Reexamination

HSIEH, HSING-CHI

Art Unit

3753

SEARCHED

Class	Subclass	Date	Examiner
137	382 527 527.8 908	8/22/2005	
128	200.29	8/22/2005	
128	204.26	8/22/2005	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
Interference Search History Printout		8/22/2005	

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
None	8/22/2005	